




PATENT

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Vickie D. Wall

Applicant : Akio Ishikawa Confirmation No. 7839  
Application No. : 10/562,751  
Filed : December 28, 2005  
Title : PATTERN COMPARISON INSPECTION METHOD AND PATTERN  
COMPARISON INSPECTION APPARATUS  
Grp./Div. : 2624  
Examiner : Joseph Mancuso  
Docket No. : 56799/A400

LETTER TO CORRECT FILING RECEIPT

Office of Initial Patent Examination's  
Filing Receipt Corrections  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Post Office Box 7068  
Pasadena, CA 91109-7068  
December 5, 2006

Commissioner:

When proofing the Filing Receipt for the above-identified application, we located the following error:

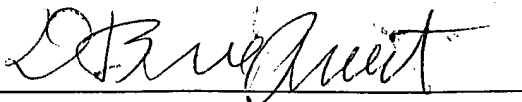
**In the Title:**

Please delete "device" and insert --apparatus-- as requested by the preliminary amendment filed December 28, 2005 (copy enclosed). A copy of the filing receipt indicating the necessary correction is also enclosed.

Please forward a Corrected Filing Receipt to the undersigned.

Respectfully submitted,

CHRISTIE, PARKER & HALE, LLP

By 

D. Bruce Prout  
Reg. No. 20,958  
626/795-9900

DBP/vdw

Enclosure: Copy of Filing Receipt

VDW PAS713329.1.\*-12/5/06 1:33 PM

DBP



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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/562,751	12/28/2005	2624	2560	56799/A400	31 ✓	16 ✓	6 ✓

CONFIRMATION NO. 7839

## FILING RECEIPT



\*OC000000020351799\*

RECEIVED

SEP 13 2006

Christie, Parker &amp; Hale, LLP

Date Mailed: 09/08/2006

23363  
 CHRISTIE, PARKER & HALE, LLP  
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Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Akio Ishikawa, Tokyo, JAPAN;

Power of Attorney: The patent practitioners associated with Customer Number **23363**.

## Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/09503 06/29/2004

## Foreign Applications

JAPAN 2003-187479 06/30/2003 ✓

If Required, Foreign Filing License Granted: 09/07/2006 ✓

**A400:**  
**56799**  
 CASE # 56799 ACTION                       
 REMINDER                      DUE DATE                       
 DEADLINE                     

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/562,751**

Projected Publication Date: 12/14/2006

Non-Publication Request: No

Early Publication Request: No

## Title

✓ Pattern comparison inspection method and pattern comparison inspection device

apparatus

**Preliminary Class**

382

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Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process **simplifies** the filing of patent applications on the same invention in member countries, but **does not result** in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

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For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, <http://www.stopfakes.gov>. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EXPRESS MAIL NO. EV351242392US

Appl No.	: N/A	Confirmation No.
Applicant	: Akio Ishikawa	
Filed	: December 28, 2005	
Title	: PATTERN COMPARISON INSPECTION METHOD AND PATTERN COMPARISON INSPECTION APPARATUS (AS AMENDED)	
TC/A.U.	: N/A	
Examiner	: N/A	
Docket No.	: 56799/A400	
Customer No.	: 23363	

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Post Office Box 7068  
Pasadena, CA 91109-7068  
December 28, 2005

Commissioner:

Prior to examination, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.

**Docket No.: 56799/A400**  
**Amdt date December 28, 2005**

**Amendments to the Specification:**

Please delete the current title and replace with the following:

-- PATTERN COMPARISON INSPECTION METHOD AND PATTERN COMPARISON  
INSPECTION APPARATUS --.

After the title please add the following:

-- CROSS-REFERENCE TO RELATED APPLICATION

This application is a National Phase Patent Application of International Application Number PCT/JP2004/009503, filed on June 29, 2004, which claims priority of Japanese Patent Application Number 2003-187479, filed on June 30, 2003. --.

Docket No.: 56799/A400  
Amdt date December 28, 2005

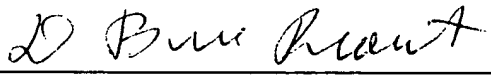
**REMARKS/ARGUMENTS**

The title was amended to correspond with the English translation.

The introduction was amended to cross reference the International and Japanese applications on which the application is based.

It is respectfully requested that the foregoing preliminary amendment be entered prior to examination.

Respectfully submitted,  
CHRISTIE, PARKER & HALE, LLP

By   
D. Bruce Prout  
Reg. No. 20,958  
626/795-9900

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AAM PAS659345.1-\* -12/28/05 1:51 PM